

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/601,071	KIM, KYEONG JIN	
Examiner		Art Unit		Page 1 of 1
Eva Yi Zheng		2611		

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0257978	12-2004	Shao et al.	370/208
*	B	US-2004/0028157	02-2004	Aoki et al.	375/347
*	C	US-2003/0124976	07-2003	Tamaki et al.	455/15
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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